

Receipt date: 09/16/2005

10549444 - GAU: 1792  
**JC20 Rec'd PCT/PTO 16 SEP 2005**  
 Date: September 16, 2005  
 Page 1 of 1

<b>U.S. DEPARTMENT OF COMMERCE</b> <b>PATENT AND TRADEMARK OFFICE</b>  <b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				ATTY. DOCKET NO.  BDL-487XX		APPLICATION NO.  <b>10/549444</b>	
				APPLICANT: Eric Sion et al.			
				FILING DATE Herewith		TC ART UNIT	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION/ ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE
	US 6,001,419	12/14/1999	Leluan et al. [Delperier]			
	US					
	US					
	US					
	US					

FOREIGN PATENT DOCUMENTS						
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES      NO	
WO 96/15285	5/23/1996	WIPO			X	

OTHER DOCUMENTS <i>(including Author, Title, Date, Pertinent Pages, etc.)</i>	
	Glasier, G.F. et al: "Formation of pyrolytic carbon during the pyrolysis of ethane at high conversions," CARBON, Elsevier Science Publishing, New York, NY, vol. 39, no.1, pages 15-23 (January 2001).
	Becker, A., et al: "Chemistry and kinetics of chemical vapor deposition of pyrocarbon—II pyrocarbon deposition from ethylene, acetylene and 1,3-butadiene in the low temperature regime," CARBON, Elsevier Science Publishing, New York, NY, vol. 36, no. 3, pages 177-199 (1998).
	Delhaes, P.: "Chemical vapor deposition and infiltration processes of carbon materials," CARBON, Elsevier Science Publishing, New York, NY, vol. 40, no. 5, pages 641-657 (April 2002).

EXAMINER      /David Turocy/	DATE CONSIDERED      03/10/2009
------------------------------	---------------------------------

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

CLG/mc/326695-1

**REFERENCES FURNISHED BY INTERNATIONAL BUREAU (PCT/FR2004/001009)**

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /D.T./